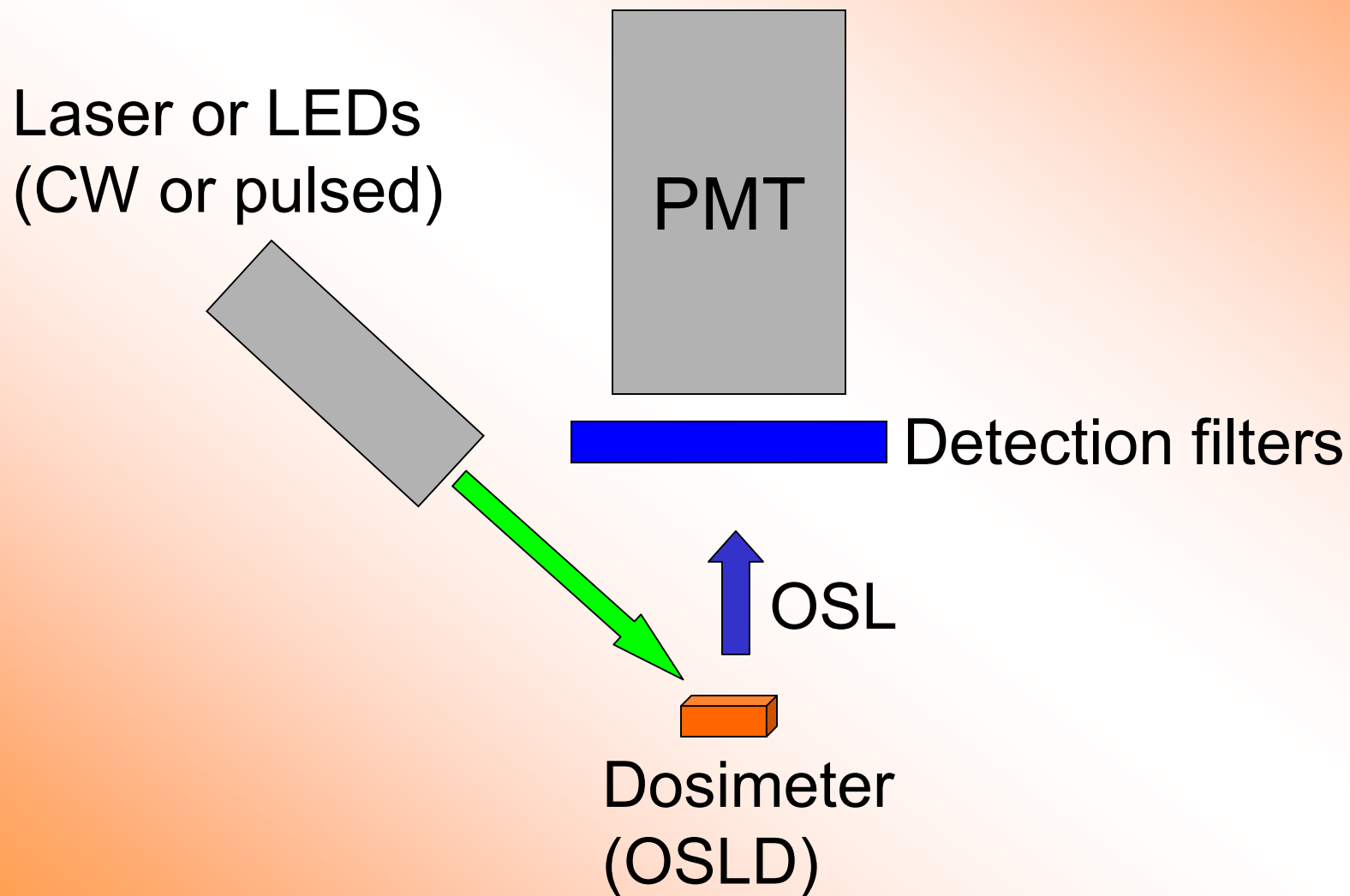

Methodological Aspects of OSL Technique Applied to Space Dosimetry

Eduardo G. Yukihiro, G. O. Sawakuchi, and S. K. Guduru
Department of Physics, Oklahoma State University

Outline

- Overview of the technique
 - Methodological developments
 - Recent results
 - Future (and present) research
-

The OSL technique

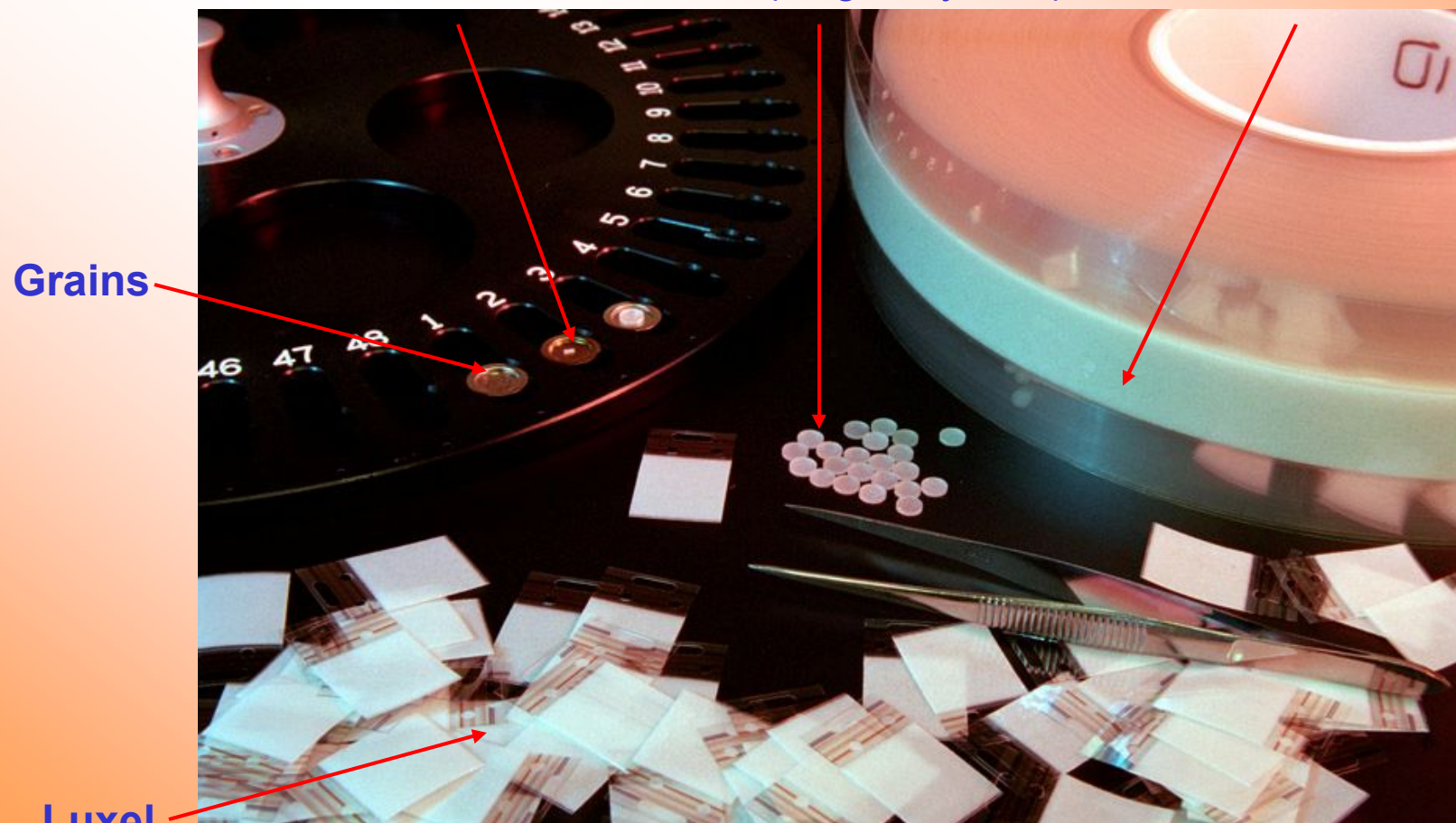


Materials

Small crystals or fibers
(single crystals)

Chips
(single crystals)

Luxel tapes
(powder in plastic film)

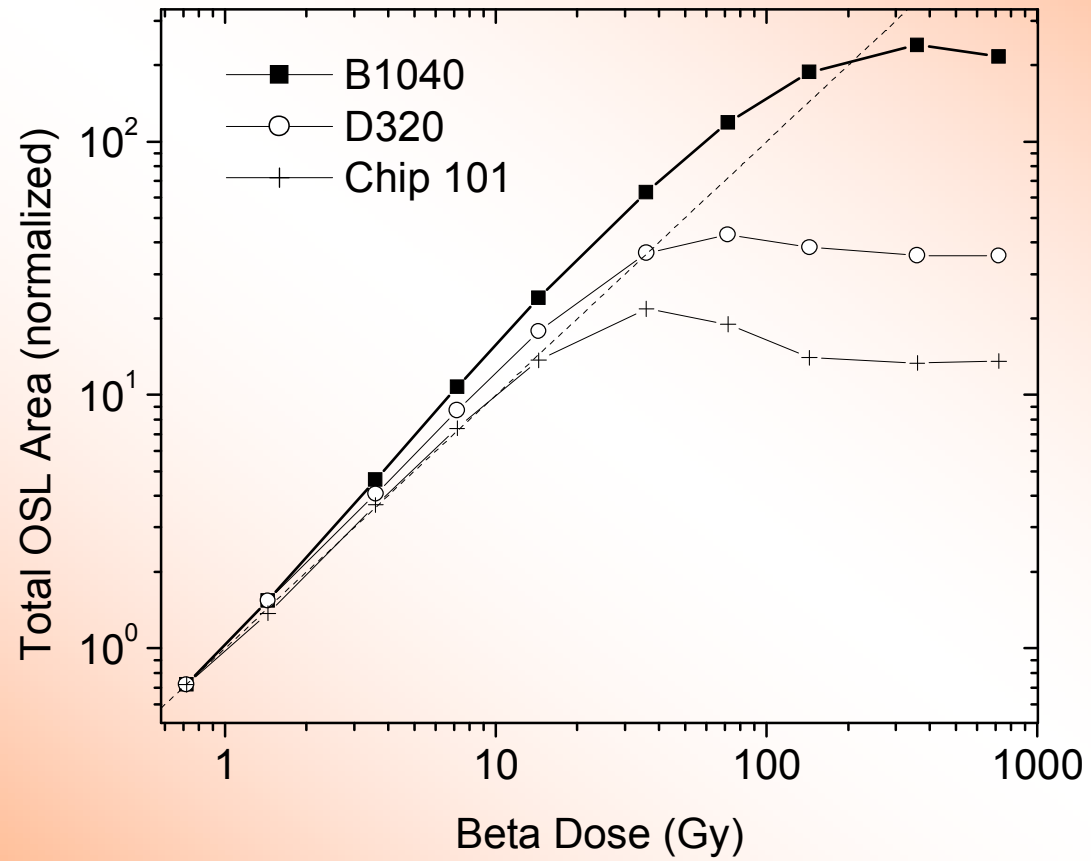


Grains

Luxel
(powder in plastic film)

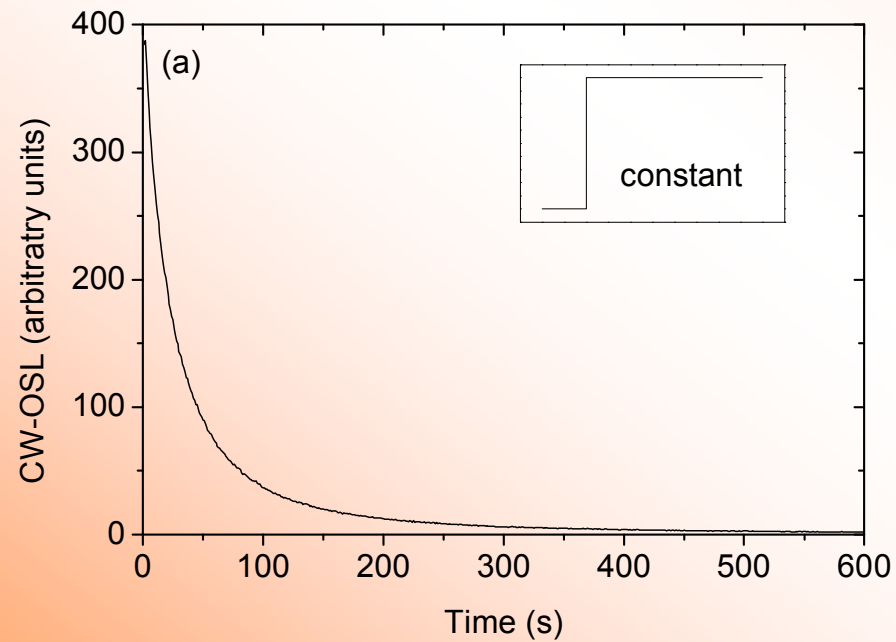
Samples provided by Landauer Inc.

Materials

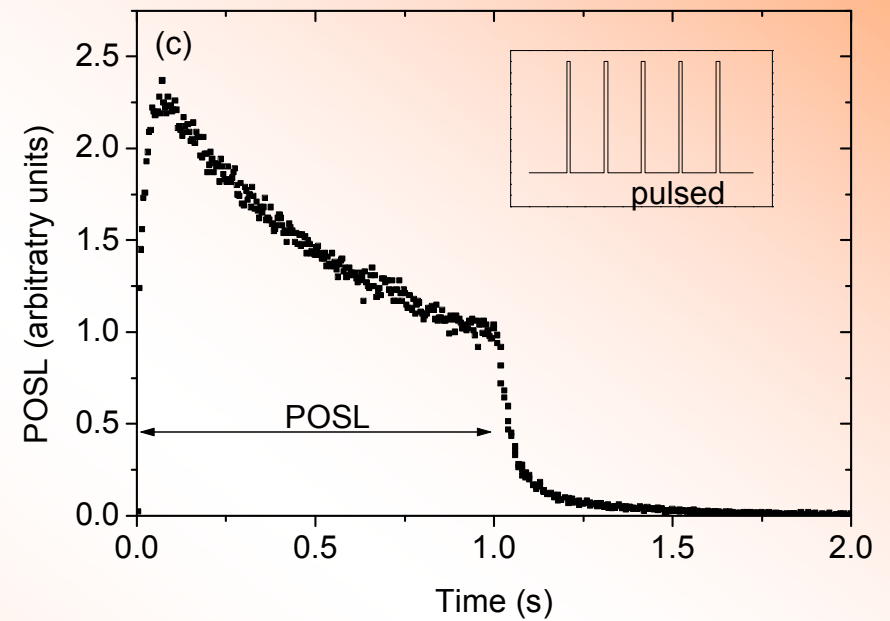


Stimulation modes

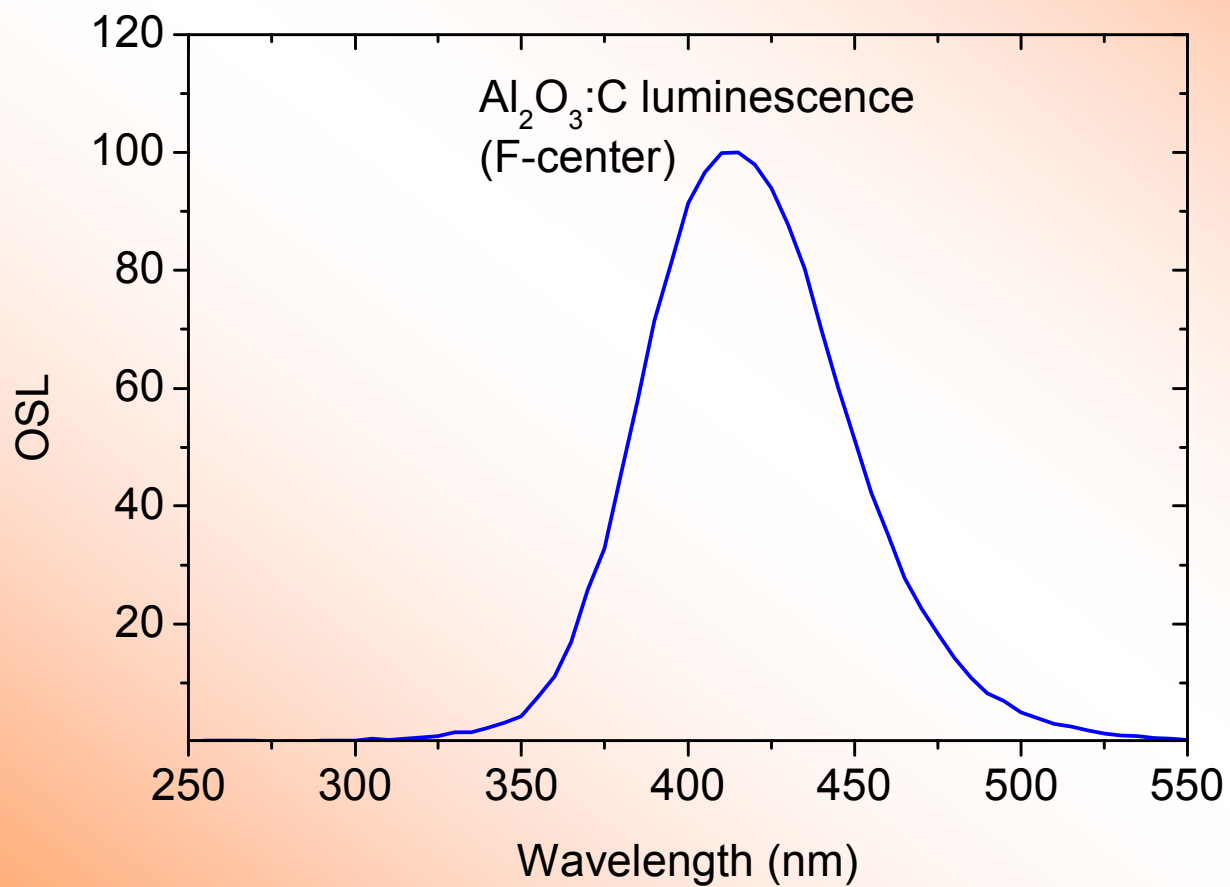
CW-OSL



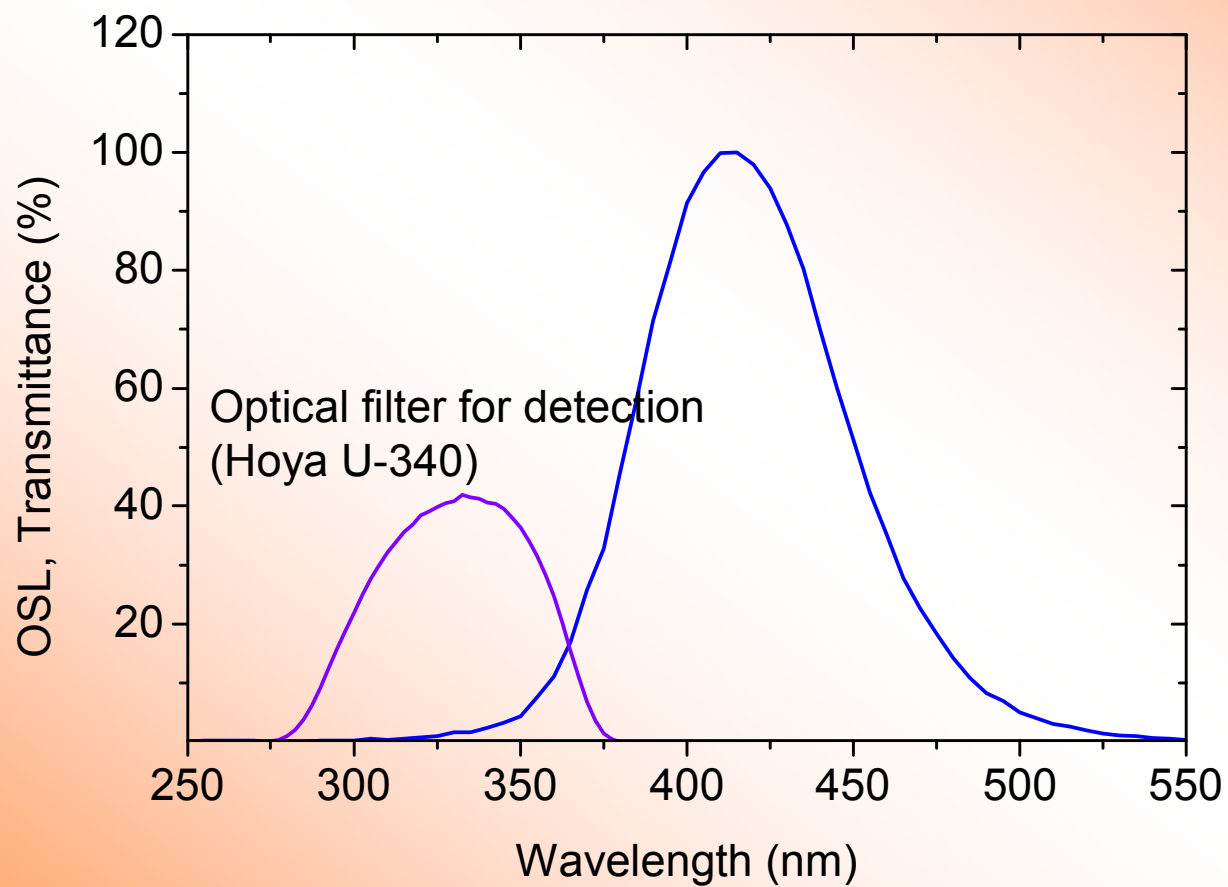
POSL



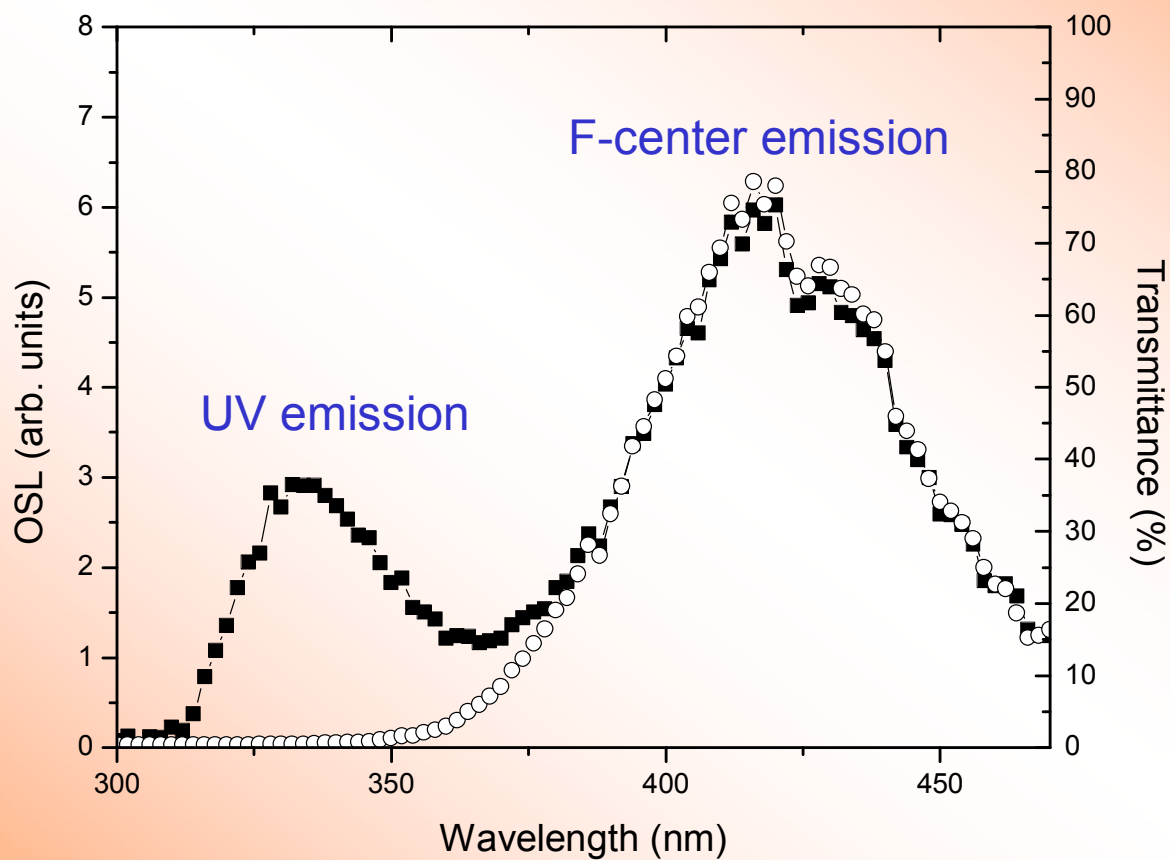
Detection



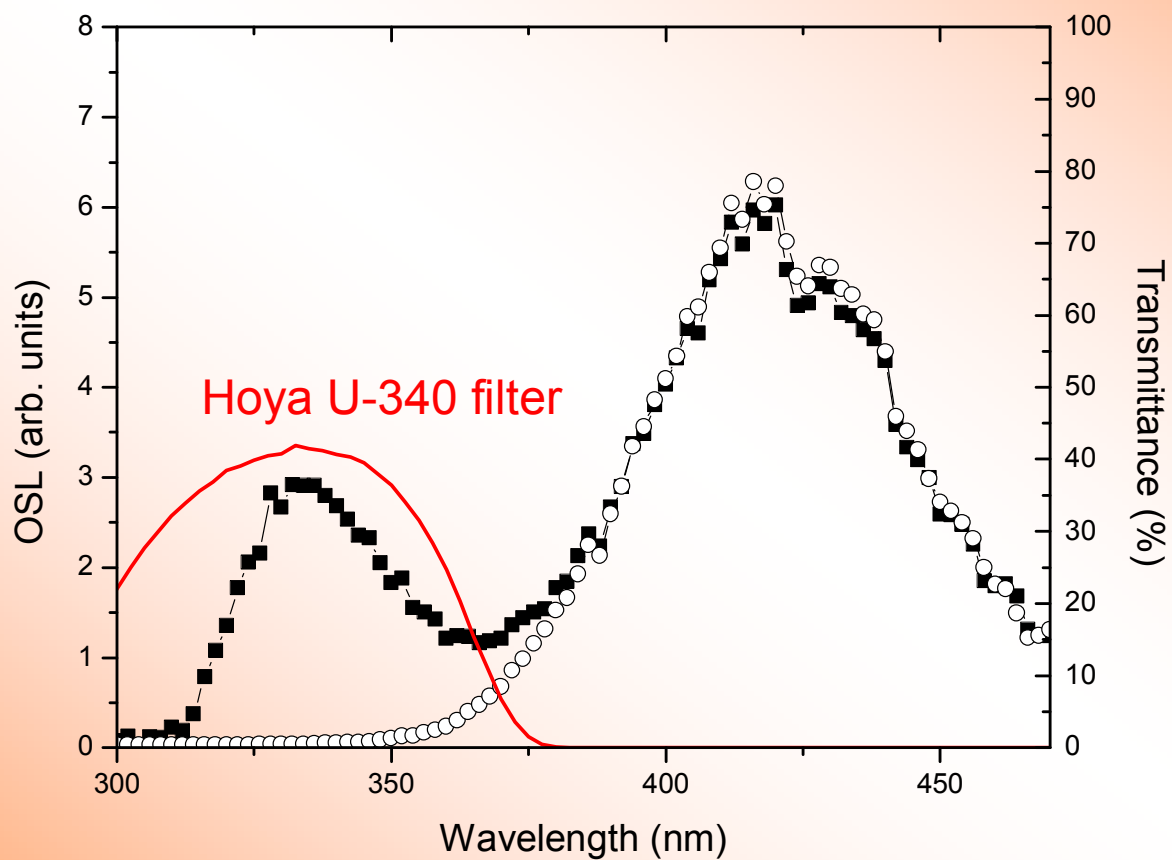
Detection



Detection



Detection



Groups working with OSL



Group	Material	Stimulation	Technique	Detection
SCK-CEN	New chips	Ar ion laser (488nm)	CW-OSL	400nm (Δ 10nm)
SRAG (NASA)	Luxel™	LEDs	CW-OSL	Hoya U-340 (290-390nm)
OSU	Old chips Luxel™	Green LEDs Nd:YAG laser (532nm)	CW-OSL POSL	Hoya U-340 (290-390nm) Corning 5-58 (410 Δ 60nm)
Landauer- Nagase	Luxel™ (?)		POSL (?)	?

Ionization density effects

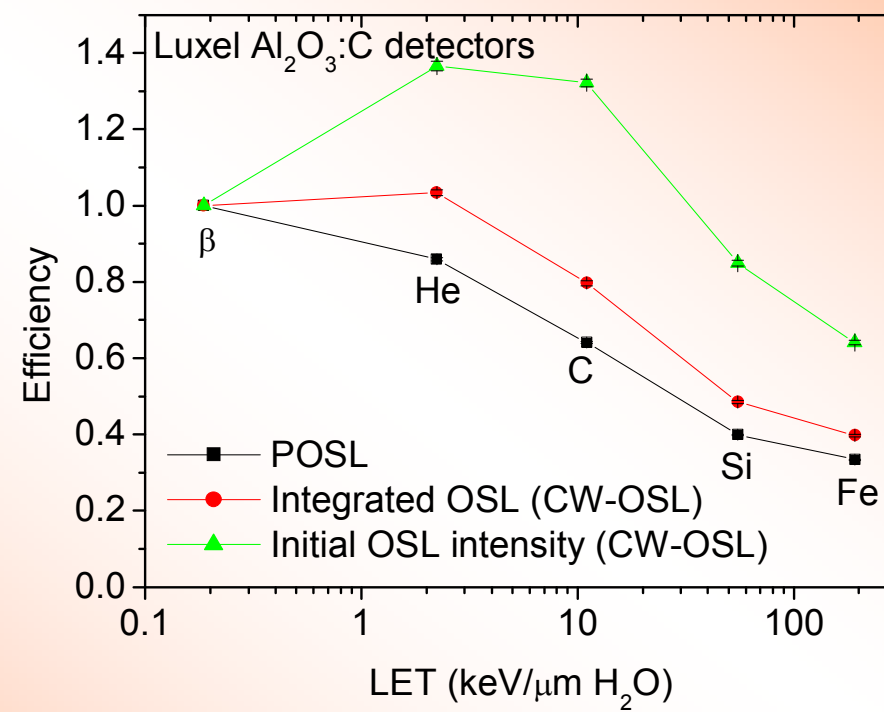
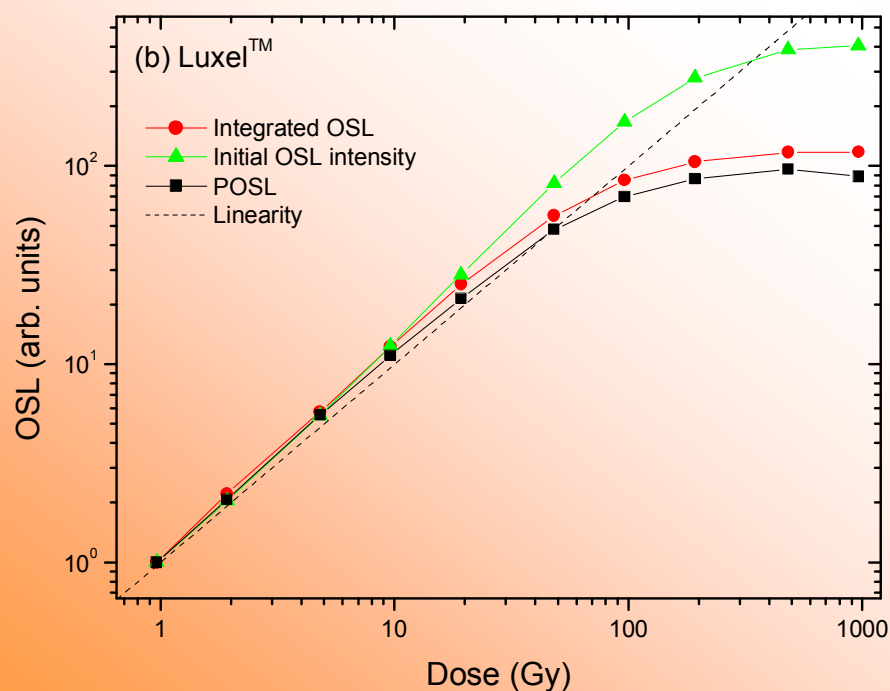
Efficiency

OSL curve

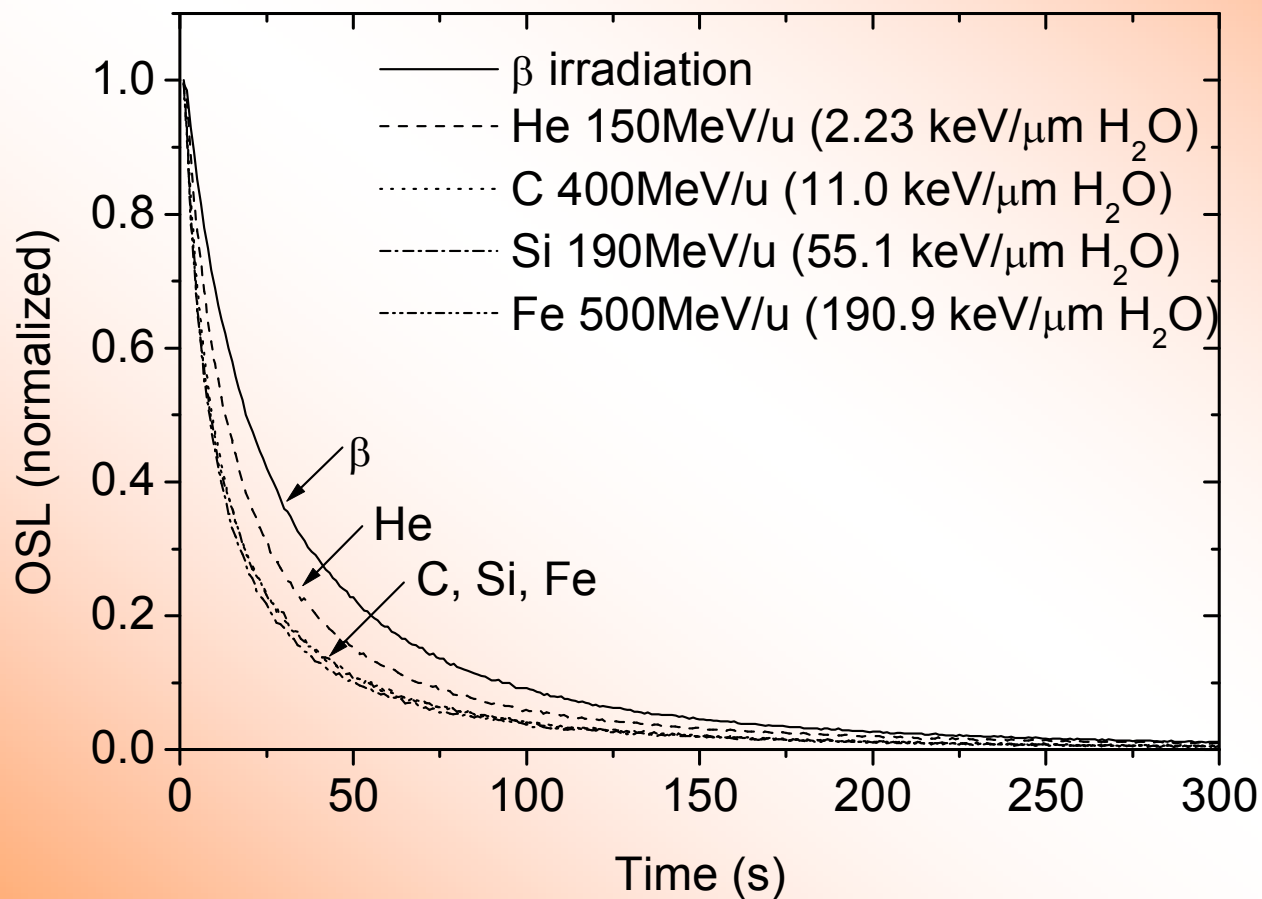
Emission spectrum

Efficiency

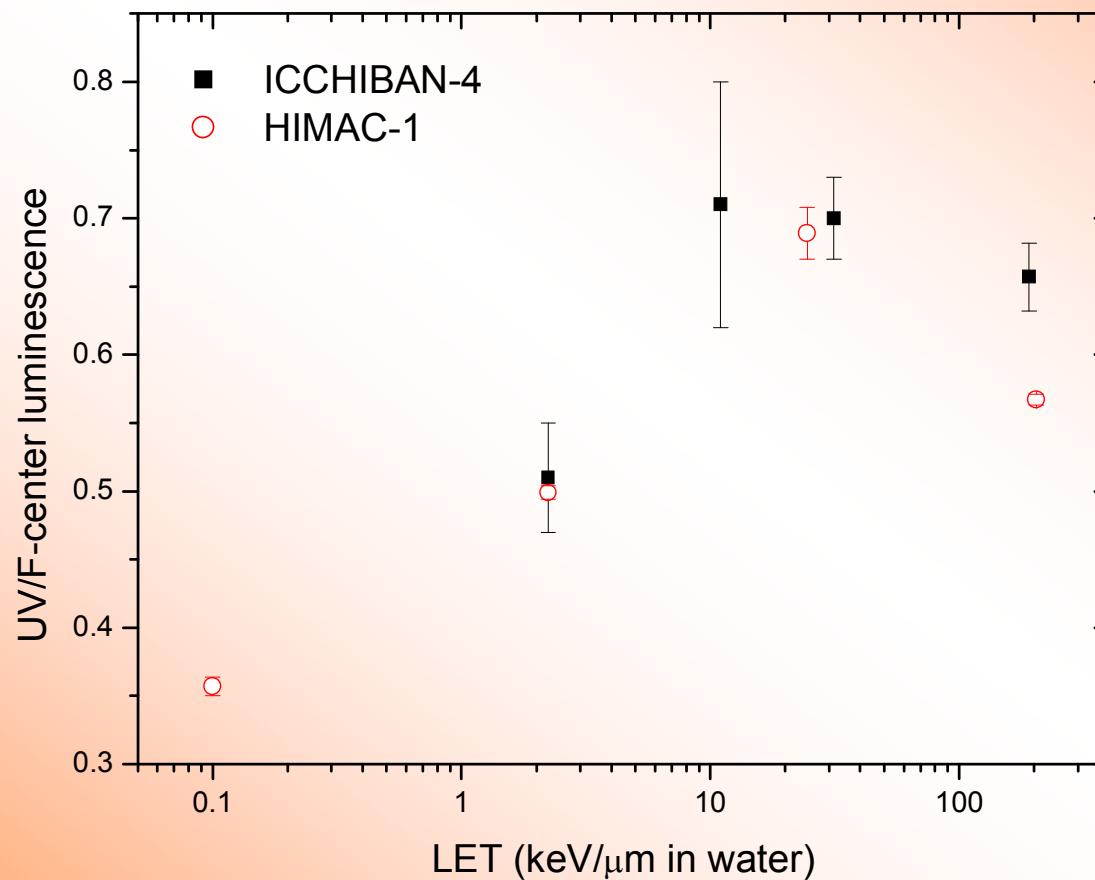
$$\eta_{HCP,\gamma} = \frac{D_{TL/OSL}}{D_{HCP}}$$



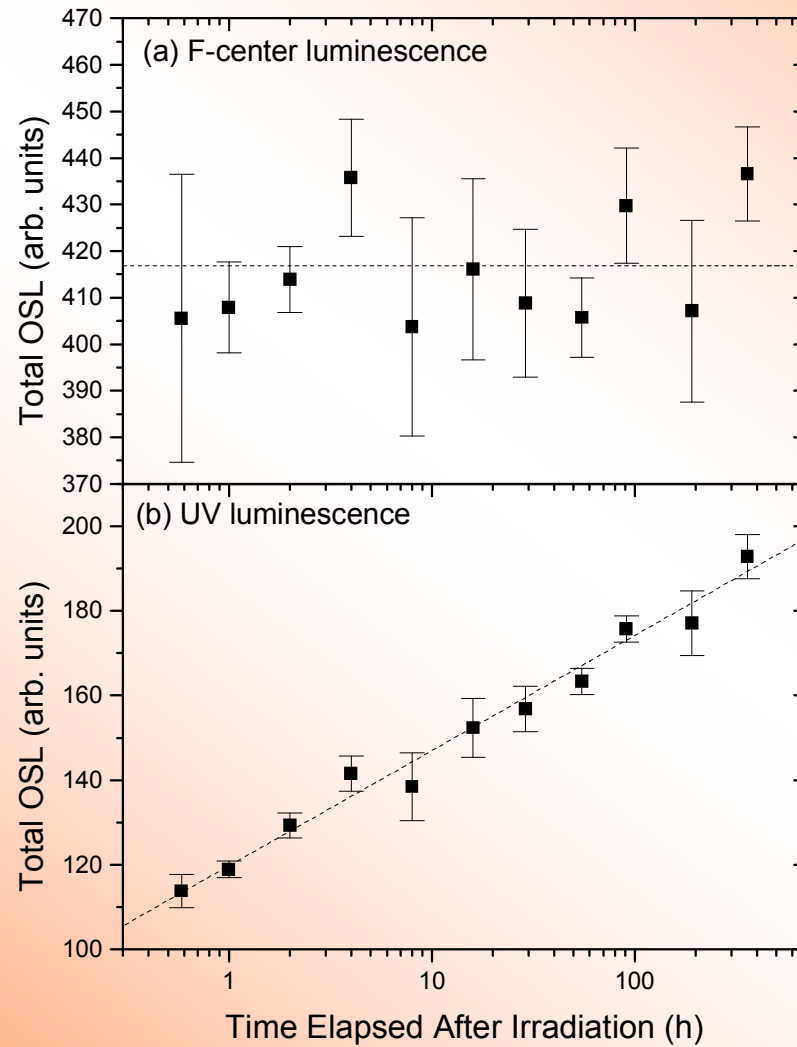
OSL curve



Emission spectrum



Emission spectrum



Brief summary so far...

Efficiencies will depend on:

- Material
- Emission band selected
 - Detection filter
 - Readout technique (CW-OSL or POSL)

Approach:

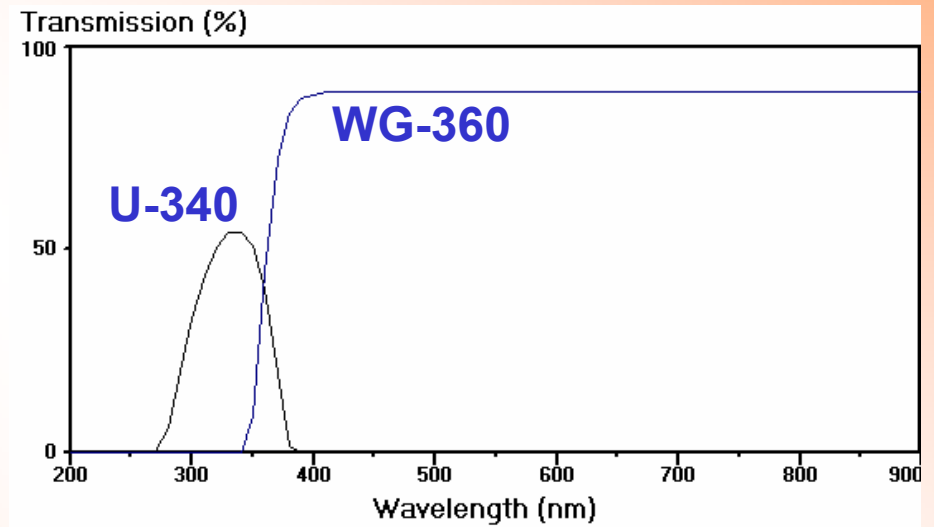
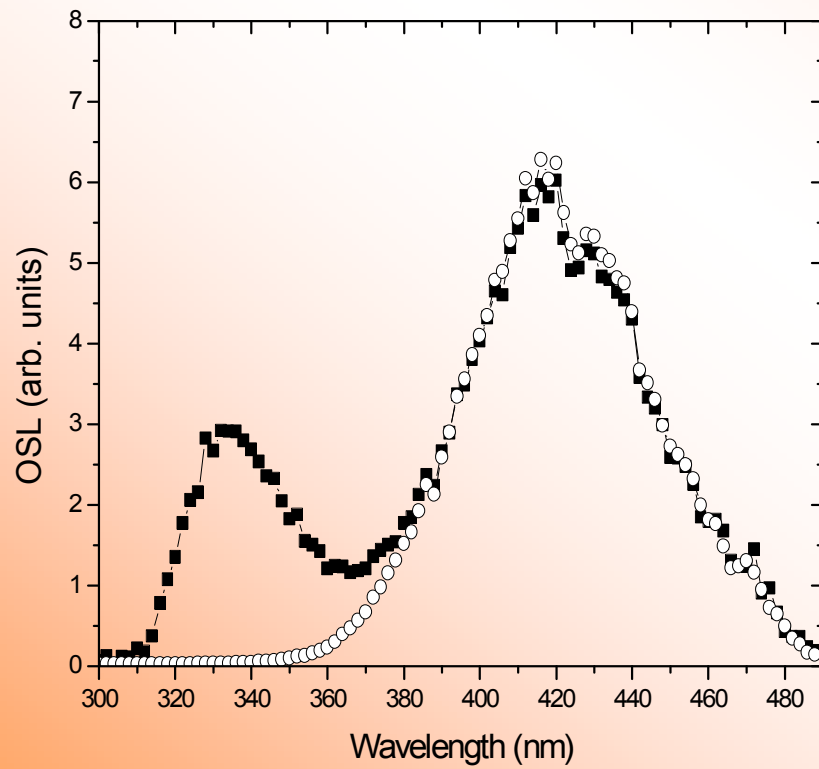
- Focus on Luxel™
 - Reduce possibility of variations in the efficiency:
 - Focus on F-center band at 420nm (CW-OSL with appropriate filters or POSL)
 - Use whole OSL curve (does not depend on stimulation power)
-

Methodological developments

Major problems:

- UV emission band
 - Time dependence
 - Different ionization density dependence
- Sensitization effects

Eliminating the UV band



Eliminating sensitization problems

No sensitivity changes:

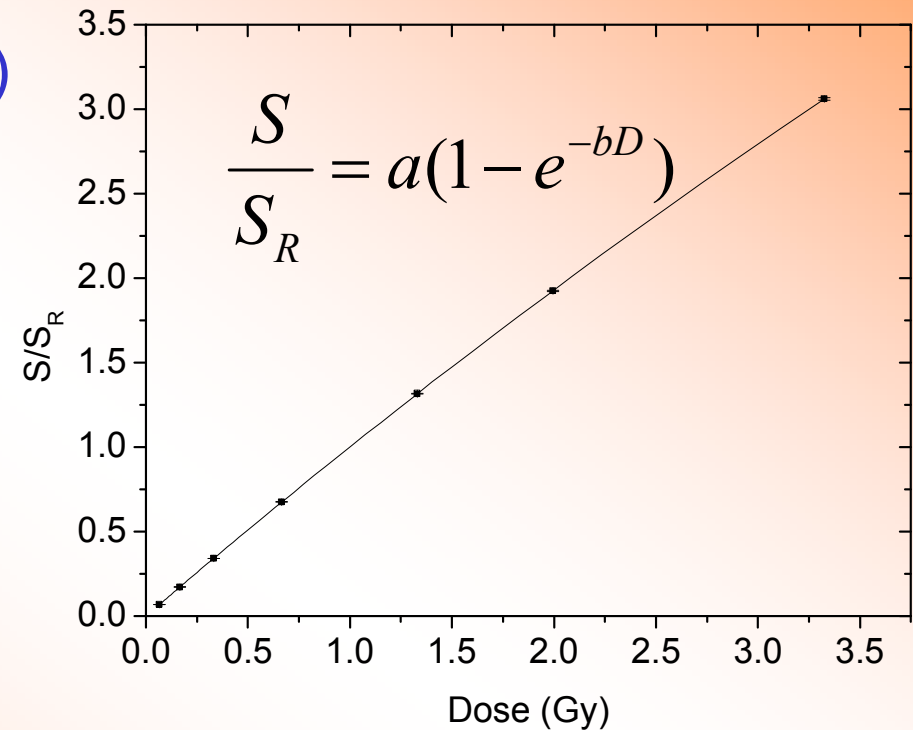
$$\left. \begin{aligned} S &= a \alpha_{equip} m D \\ S_R &= a \alpha_{equip} m D_R \end{aligned} \right\} \frac{S}{S_R} = \frac{D}{D_R}$$

With sensitivity changes:

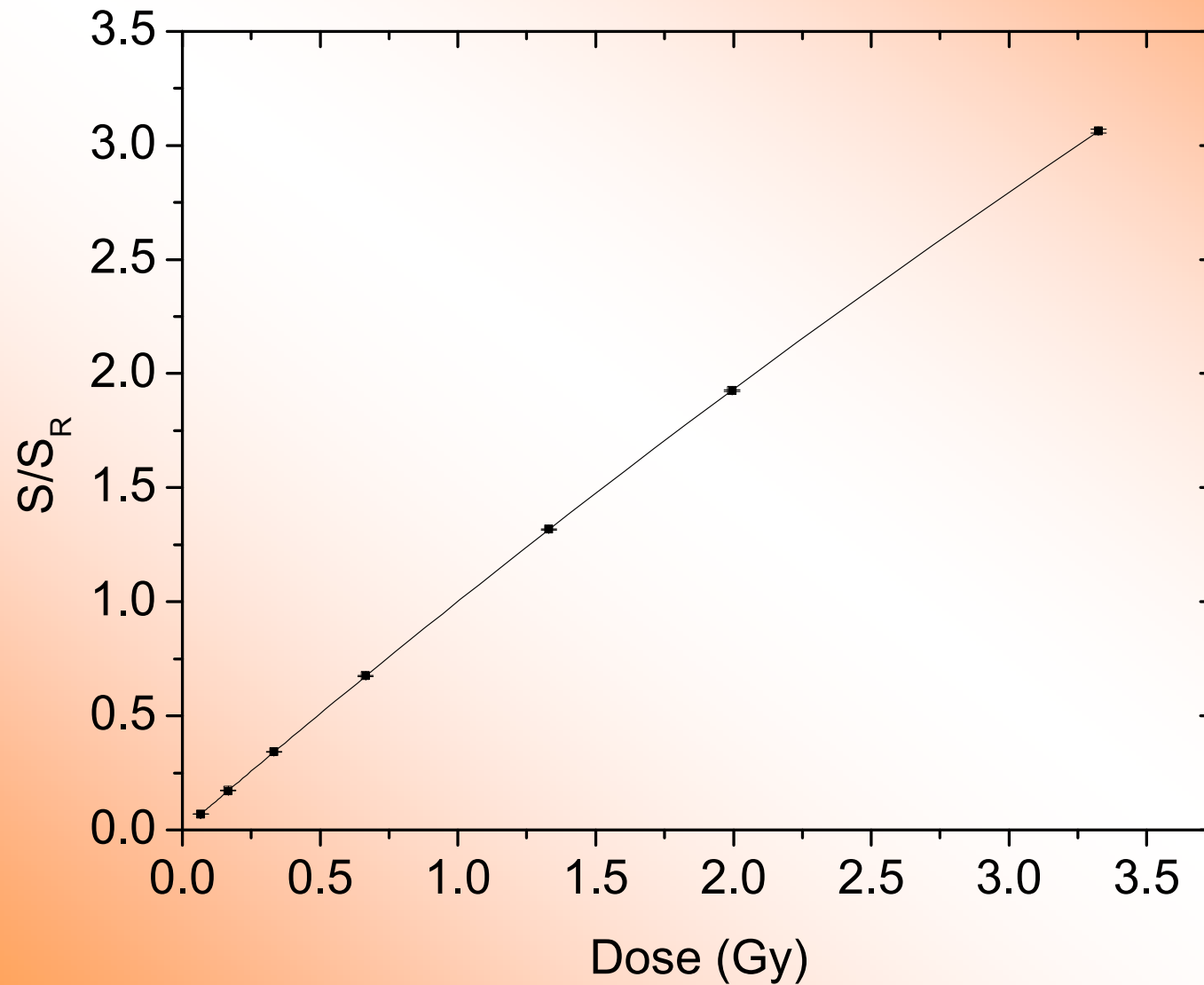
$$\left. \begin{aligned} S &= a(D) \alpha_{equip} m D \\ S_R &= a(D, D_R) \alpha_{equip} m D_R \end{aligned} \right\} \frac{S}{S_R} = f(D)$$

Eliminating sensitization problems

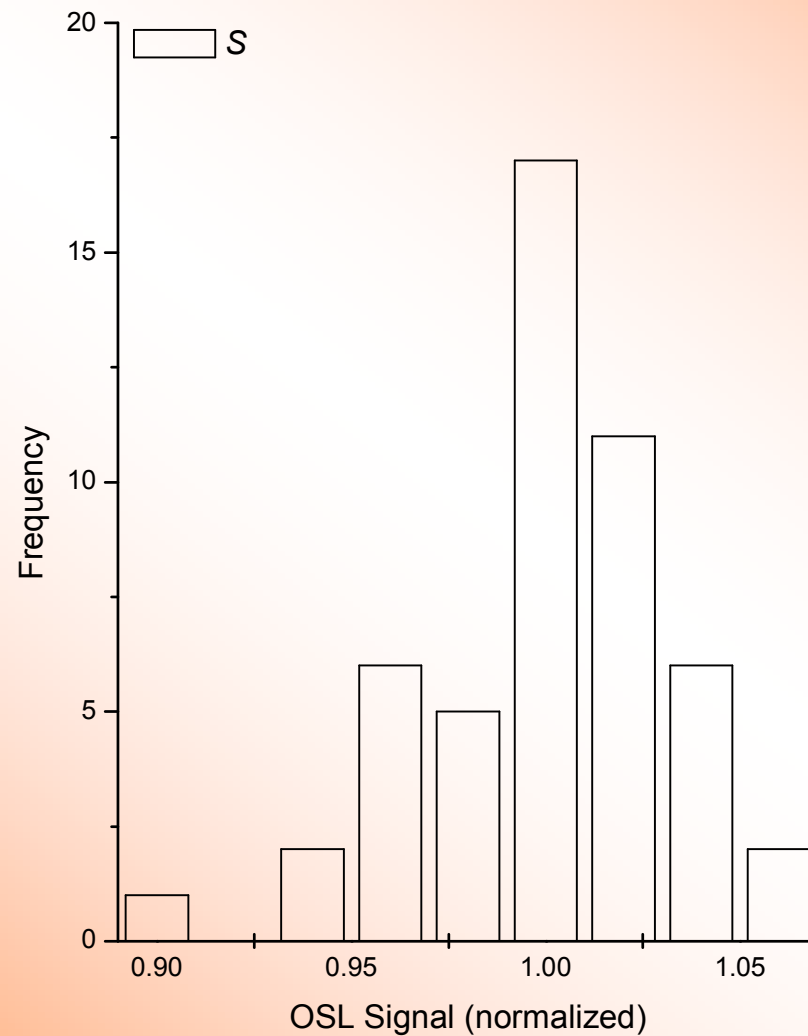
- (1) Measure S (OSL readout)
- (2) Irradiate with reference dose D_R
- (3) Measure S_R
- (4) Calculate S/S_R



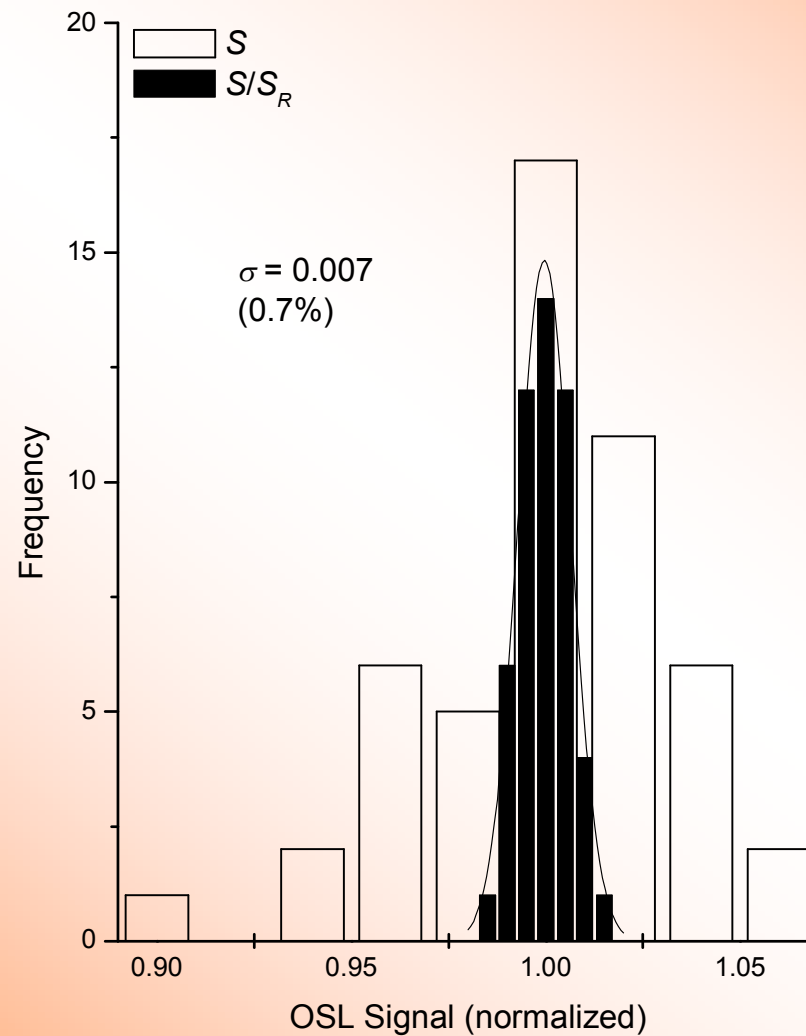
Eliminating sensitization problems



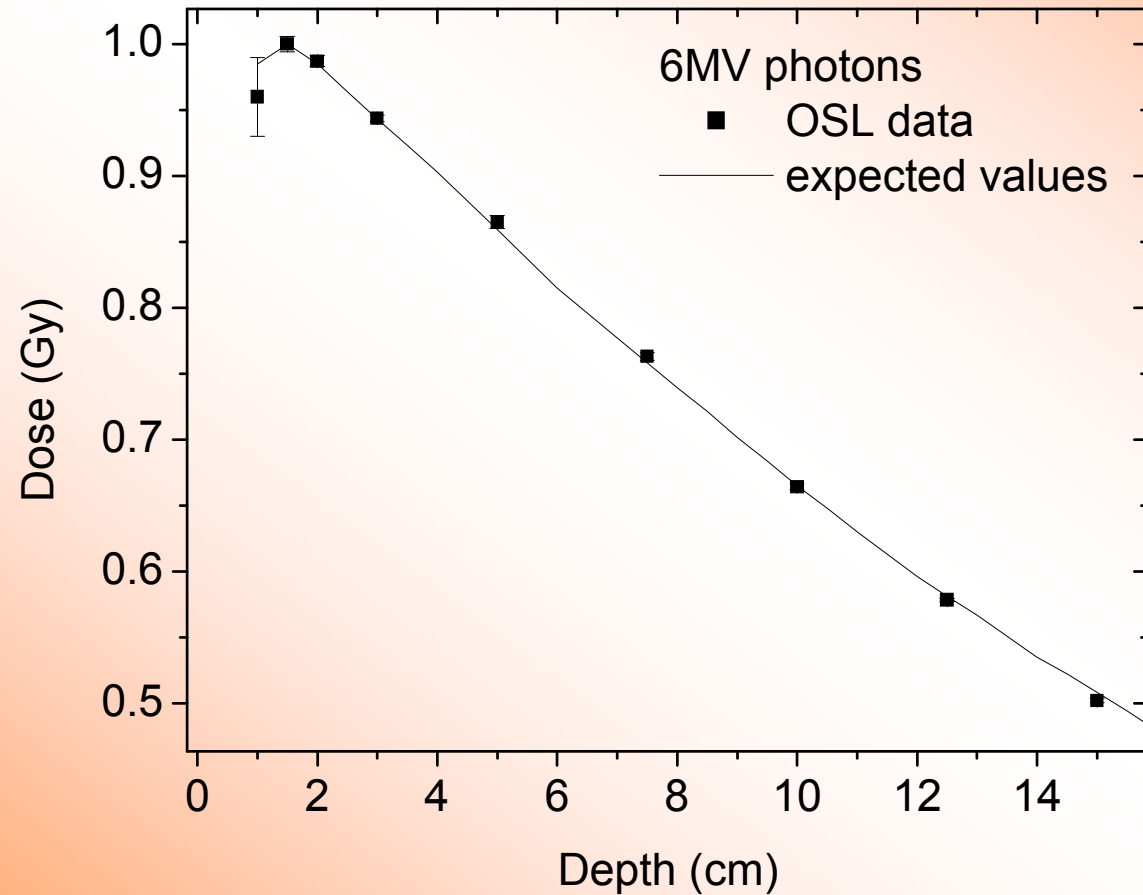
Eliminating sensitization problems



Eliminating sensitization problems



Results: depth dose profiles



Results: reproducibility

He 150MeV/u

D_{HCP} (mGy)	η	
100.5	0.909	
	0.919	
	0.910	
100.4	0.911	
	0.893	
	0.903	
100.5	0.907	
	0.930	
	0.905	
100.0	0.929	
	0.910	
	0.893	
100.5	0.904	
	0.917	
	0.923	

Results: reproducibility

He 150MeV/u

D_{HCP} (mGy)	η	SD (%)
100.5	0.909	0.6%
	0.919	
	0.910	
100.4	0.911	1.0%
	0.893	
	0.903	
100.5	0.907	1.5%
	0.930	
	0.905	
100.0	0.929	1.9%
	0.910	
	0.893	
100.5	0.904	1.0%
	0.917	
	0.923	

Results: reproducibility

He 150MeV/u

$\sigma = 0.6\%$

D_{HCP} (mGy)	$\eta_{average}$	SD (%)
100.5	0.912	0.6%
100.4	0.902	1.0%
100.5	0.914	1.5%
100.0	0.910	1.9%
100.5	0.915	1.0%

Results: reproducibility

C 400MeV/u

D_{HCP} (mGy)	η	SD (%)
100.5	0.676 0.671 0.666	1.7%
100.4	0.660 0.671 0.684	0.7%
100.4	0.673 0.662 0.675	1.3%
100.6	0.662 0.666 0.674	1.6%
100.7	0.663 0.672 0.652	0.9%

Results: reproducibility

C 400MeV/u

$\sigma = 0.9\%$

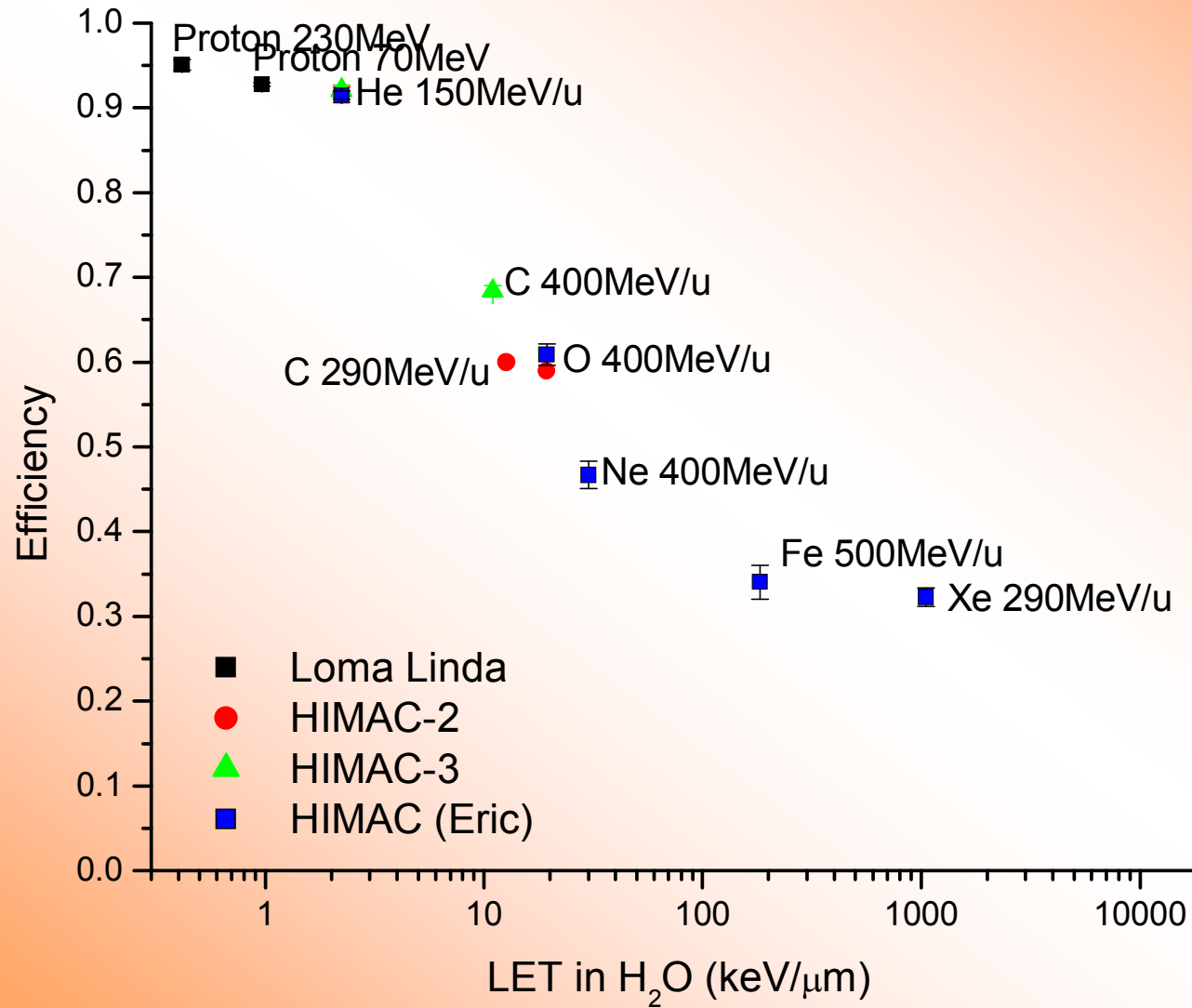
D_{HCP} (mGy)	$\eta_{average}$	SD (%)
100.5	0.656	1.7%
100.4	0.660	0.7%
100.4	0.660	1.3%
100.6	0.663	1.6%
100.7	0.671	0.9%

Results: beam uniformity

He 150MeV/u

-1.5%			1.1%			0.9%
			0.3%			
		-1.8%	-0.6%	-0.2%		
2.5%	-0.5%	-0.1%	-0.6%	-0.3%	0.6%	0.01%
		-0.5%	-2.3%	0.1%		
			0.3%			
2.5%			0.1%			-0.1%

Results: efficiencies



Conclusions

- With new methodology, efficiency for most groups should be comparable
 - Time-dependence of the UV emission band is avoided
 - Higher precision is achieved
-

Future (and present) research:

- Efficiency different than 1 for low LET particles should be investigated for various materials
 - Ionization-density-dependent phenomena may help to correct for these variations
-

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 - Chris Soares (NIST)
 - Dr. Stephen McKeever
 - Landauer Inc.
 - NIRS
 - WRMISS organizers

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